

**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**  
( Not for submission under 37 CFR 1.99)

Application Number

Filing Date

First Named Inventor

Philippe Renaud

Art Unit

Examiner Name

Attorney Docket Number

SC12993ET

**U.S. PATENTS**

| Examiner Initial* | Cite No | Patent Number | Kind Code <sup>1</sup> | Issue Date | Name of Patentee or Applicant of cited Document | Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear |
|-------------------|---------|---------------|------------------------|------------|---|--|
| /DG/              | 1       | 5834825       | A                      | 1998-11-10 | Imai  |  |
| /DG/              | 2       | 6396122       | B1                     | 2002-05-28 | Liu et al                                       |  |
| /DG/              | 3       | 6254662       | B1                     | 2001-07-03 | Murray et al                                    |  |

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|-------------------|---------|--------------------|------------------------|------------------|---|--|
| /DG/              | 1       | 20030035887        | A1                     | 2003-02-20       | Baglin et al                                    |  |
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**FOREIGN PATENT DOCUMENTS**

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| First Named Inventor   | Philippe Renaud |           |  |
| Art Unit               |                 |           |  |
| Examiner Name          |                 |           |  |
| Attorney Docket Number |                 | SC12993ET |  |

|      |   |            |    |    |            |                 |                          |
|------|---|------------|----|----|------------|-----------------|--------------------------|
|      | 1 | 2003347123 | JP | A  | 2003-12-05 | Taiyo Yuden Co. | <input type="checkbox"/> |
| /DG/ | 2 | 07211865   | JP | A  | 1995-08-11 | Fujitsu         | <input type="checkbox"/> |
| /DG/ | 3 | 19533050   | DE | A1 | 1997-03-13 | Vacuumschmelze  | <input type="checkbox"/> |

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|--------------------|---------|---|--------------------------|
| /DG/               | 1       | GROMOV et al; "Electromagnetic Analysis of Layered Magnetic/Conductor Structures"; Royal Inst. of Technology, Sweden, 2000, J. Phys. D: Appl. Phys. 33, pp 773  | <input type="checkbox"/> |

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**EXAMINER SIGNATURE**

|                    |                 |                 |            |
|--------------------|-----------------|-----------------|------------|
| Examiner Signature | /David Goodwin/ | Date Considered | 07/23/2009 |
|--------------------|-----------------|-----------------|------------|

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through a citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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| Examiner Name          |                 |  |
| Attorney Docket Number | SC12993ET       |  |

## **CERTIFICATION STATEMENT**

Please see 37 CFR 1.97 and 1.98 to make the appropriate selection(s):

- ☐ That each item of information contained in the information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement. See 37 CFR 1.97(e)(1).

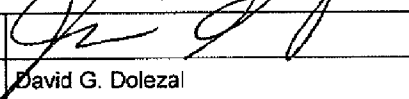
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- ☐ See attached certification statement.
- ☐ Fee set forth in 37 CFR 1.17 (p) has been submitted herewith.
- ☒ None

### **SIGNATURE**

A signature of the applicant or representative is required in accordance with CFR 1.33, 10.18. Please see CFR 1.4(d) for the form of the signature.

|            |   |                     |            |
|------------|---|---------------------|------------|
| Signature  |  | Date (YYYY-MM-DD)   | 2006-06-09 |
| Name/Print | David G. Dolezal  | Registration Number | 41,711     |

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